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Bib Data Sheet

SERIAL NUMBER 09/977,238	FILING DATE 10/16/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SEC.895
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APPLICANTS

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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2000-61717 10/19/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/15/2001

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 21	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials			

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TITLE

Method and apparatus for numerically analyzing grain growth on semiconductor wafer using SEM image

FILING FEE RECEIVED 1022	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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